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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kenji NISHI

Appln. No.: 08/994,758



Group Art Unit: 2851

Filed: December 19, 1997

Examiner: A. Mathews

For: PROJECTION EXPOSURE APPARATUS

* * *

SUPPLEMENTAL AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Supplementing the Amendment filed May 11, 2000, please further amend the above-identified patent application as indicated below.

IN THE CLAIMS:

Please add the following claims:

1 --171. An apparatus according to Claim 143, wherein
2 said first stage holds the original and said second stage
3 holds the substrate, and wherein said first stage is
4 provided above said second stage.--

1 --172. A scanning exposure method in which in
2 synchronism with movement of a first object formed with a